## AMENDMENTS TO THE ABSTRACT OF THE DISCLOSURE:

Please replace the Abstract of the Disclosure with the following new Abstract.

Alt is an object of the present invention to provide a corrosion resistant thermal type mass flow rate sensor, and a fluid supply device employing for which the sensor is employed, are provided thus allowing to enhanced corrosion resistance of the thermal type mass flow rate sensor, improve responsiveness, achieve to be achieved particle-free, and to prevent unevenness of product qualities. A

Concretely, a thermal type mass flow rate sensor is constituted with a sensor part 1 comprising a corrosion resistant metal substrate 2 formed asto be a thin plate by applying electrolytic etching on the rear face side of a corrosion resistant metal material W, and a thin film F to-forming a temperature sensor 3 and a heater 4 mounted on the rear face side of the said corrosion resistant metal substrate 2, and a sensor base 13 hermetically fitted by welding to the outer periphery of the corrosion resistant metal substrate 2 of the afore-mentioned sensor part 1 fitted into a fixture groove 13a.